

In re application of:

Gontin et al.

Appl. No.: 10/651,049

Filed: August 29, 2003

For: Speckle Reduction Method and System for EUV Interferometry

Confirmation No.: 8532

Art Unit: 2877

Examiner: Detschel, Marissa

Atty. Docket: 1857.2080000

Information Disclosure Statement

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Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

Listed on accompanying IDS Forms are documents that may be considered material to the examination of this application, in compliance with the duty of disclosure requirements of 37 C.F.R. §§ 1.56, 1.97 and 1.98.

Where the publication date of a listed document does not provide a month of publication, the year of publication of the listed document is sufficiently earlier than the effective U.S. filing date and any foreign priority date so that the month of publication is not in issue. Applicants have listed publication dates on the attached IDS Forms based on information presently available to the undersigned. However, the listed publication dates should not be construed as an admission that the information was actually published on the date indicated.

Applicants reserve the right to establish the patentability of the claimed invention over any of the information provided herewith, and/or to prove that this information may

not be prior art, and/or to prove that this information may not be enabling for the teachings purportedly offered.

This statement should not be construed as a representation that a search has been made, or that information more material to the examination of the present patent application does not exist. The Examiner is specifically requested not to rely solely on the material submitted herewith.

Applicants have checked the appropriate boxes below.

- ☐ 1. Statement under 37 C.F.R. 1.704(d). Each item of information contained in this
 Information Disclosure Statement was cited in a communication from a foreign
 patent office in a counterpart application and this communication was not
 received by any individual designated in 37 C.F.R. § 1.56(c) more than thirty
 days prior to the filing of this information disclosure statement.
- 2. Filing under 37 C.F.R. § 1.97(b). This Information Disclosure Statement is being filed within three months of the date of filing of a national application other than a continued prosecution application (CPA), OR within three months of the date of entry of the national stage as set forth in 37 C.F.R. § 1.491 in an international application, OR before the mailing date of a first Office Action on the merits OR before the mailing of a first Office Action after the filing of a request for continued examination under 37 C.F.R. § 1.114. No statement or fee is required.
- 3. Filing under 37 C.F.R. § 1.97(c). This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date

of the first Office Action on the merits, but before the mailing date of a Final Rejection, or Notice of Allowance, or an action that otherwise closes prosecution in the application.

- a. Statement under 37 C.F.R. § 1.97(e)(1). I hereby state that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(1).
- b. Statement under 37 C.F.R. § 1.97(e)(2). I hereby state that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(2).
- c. Attached is our PTO-2038 Credit Card Payment Form in the amount of \$_____ in payment of the fee under 37 C.F.R. § 1.17(p).
- 4. Filing under 37 C.F.R. § 1.97(d) This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee.

Enclosed find our PTO-2038 Credit Card Payment Form in the amount of \$180.00 in payment of the fee under 37 C.F.R. § 1.17(p); in addition:

- a. Statement under 37 C.F.R. § 1.97(e)(1). I hereby state that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(1).
- b. Statement under 37 C.F.R. § 1.97(e)(2). I hereby state that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(2).
- Some of the documents were cited in search reports by a foreign patent office in counterpart foreign applications. Submission of an English language version of the search reports that indicate the degree of relevance found by the foreign office is provided in satisfaction of the requirement for a concise explanation of relevance. 1138 OG 37, 38.
- 6. A concise explanation of the relevance of the non-English language document(s) appears below in accordance with 37 C.F.R. § 1.98(a)(3).

⊠ 7.	Copies of documents FP1-FP5 and NPL1-NPL13 are submitted. However, in
	accordance with 37 C.F.R. § 1.98(a)(2), no copies of U.S. patents and patent
	application publications cited on the attached IDS Forms are submitted.
□ 8.	Copies of the documents were cited by or submitted to the Office in an IDS that
	complies with 37 C.F.R. § 1.98(a)-(c) in Application No, filed
	, which is relied upon for an earlier filing date under 35 U.S.C.
	§ 120. Thus, copies of these documents are not attached. 37 C.F.R. § 1.98(d).
□ 9.	It is expected that the examiner will review the prosecution and cited art in the
	parent application no(s) in accordance with MPEP 2001.06(b),
	and indicate in the next communication from the office that the art cited in the
	earlier prosecution history has been reviewed in connection with the present
	application.

It is respectfully requested that the Examiner initial and return a copy of the enclosed IDS Forms, and indicate in the official file wrapper of this patent application that the documents have been considered.

Gontin *et al.* Appl. No. 10/651,049

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

Donald J. Featherstone Attorney for Applicants

Registration No. 33,876

Date:

1100 New York Avenue, N.W. Washington, D.C. 20005-3934 (202) 371-2600

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of

(Use as many sheets as necessary)

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Complete if Known				
Application Number	10/651,049			
Filing Date	August 29, 2003			
First Named Inventor	Richard A. Gontin			
Art Unit	2877			
Examiner Name	Detschel, Marissa			
Attorney Docket Number	1857.2080000			

			U.S. PATENT DO	CUMENTS	
Examiner	Cite	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines,
Initials*	No.1	Number-Kind Code ^{2 (If Known)}	MM-DD-YYYY	Applicant of Cited Document	Where Relevant Passages or Relevant Figures Appear
	US1	5,486,950	01/1996	Collinge	
	US2	5,641,593	06/1997	Watanabe et al.	
	US3	5,958,629	09/1999	Yan et al.	
	US4	6,057,082	05/2000	Korth	
	US5	6,072,631	06/2000	Guenther et al.	
	US6	6,163,405	12/2000	Chang et al.	
	US7	6,392,792 B1	05/2002	Naulleau	
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-,	US14	5,715,039	02/1998	Fukuda et al.	
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	US16	5,222,050	06/1993	Marren et al.	
	US17	6,373,553	03/2002	Singh	
	US18	6,573,997	06/2003	Goldberg et al.	
	US19	6,650,399	11/2003	Baselmans et al.	
	US20	6,392,792	06/2002	Naulleau	

		Fo	REIGN PATENT DO	CUMENTS		
Examiner Initials*	Cite No.1		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where	
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)			Relevant Passages or Relevant Figures Appear	Τé
	FP1	EP 1 106 972 A1	06/2001	Henshaw		
	FP2	EP 1 197 803 A2 & A3	04/2002	Van Elp et al.		
	FP3	EP 1 237 041 A2 & A3	09/2002	Subhash et al.		
	FP4	JP 2000-266914	09/2000	Toshitaka		
_	FP5	EP 1 231 514 A1	08/2002	ASML Netherlands B.V.		
	FP6					
	FP7					
	FP8					
	FP9					

Examiner	Date	
Signature	Considered	

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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Substitute f	or form	1449/PT	0	Complete	if Known
				Application Number	10/651,049
INFOR	MA'	ΓΙΟΝ	DISCLOSURE	Filing Date	August 29, 2003
STATEMENT BY APPLICANT			APPLICANT	First Named Inventor	Richard A. Gontin
(Use as many sheets as necessary)				Art Unit	2877
			•	Examiner Name	Detschel, Marissa
Sheet	2	of	2	Attorney Docket Number	1857.2080000

			U.S. PATENT DO	OCUMENTS	
Examiner Initials	Cite No. 1 Document Number Publication Date MM-DD-YYYY Number-Kind Code ² (If Known)		Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages
illitiais		MINI-DD-1111	Applicant of Cited Bocamont	or Relevant Figures Appear	
	US21	4,413,909	11-08-1993	Pohle	
	US22	6,360,012	03-19-2002	Kreuzer	
	US23				
	US24				
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	US40				

			FOREIGN PATENT DO	CUMENTS		
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ Number ⁴ Kind Code ³ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
	FP10					
	FP11					
	FP12					
	FP13					Ш
	FP14					
	FP15					Ш
	FP16					
	FP17					
	FP18					

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Substitute for form 1449/PTO	Complete if Known		
	Application Number	10/651,049	
INFORMATION DESCLOSURE	Filing Date	August 29, 2003	
STATEMENT BY APPLICANTS	First Named Inventor	Richard A. Gontin	
STATEMENT BY APPLICANTS (Use as many sheets as ACCOUNTS)	Art Unit	2877	
	Examiner Name	Detschel, Marissa	
Sheet 1 of 2	Attorney Docket Number	1857.2080000	

- ·	C C :	NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume issue number(s), publisher, city and/or country where published	T ²
	NPL1	Bjorkholm, J. E., "EUV Lithography - The Successor to Optical Lithography?", Intel Technology Journal Q3'98, 1998, pp. 1-8.	
	NPL2	Goldberg, K.A., et al., "Extreme ultraviolet interferometry: at-wavelength testing of optics for lithography," The Advanced Light Source, 1998, at http://www-als.lbl.gov/als/compendium/ AbstractManager/uploads/ACF4B6D.pdf, 4 pages.	
	NPL3	Goldberg, K.A., et al., "Extreme ultraviolet interferometry: measuring EUV optical systems with sub-Å accuracy," The Advanced Light Source, 2001, at http://www-als.lbl.gov/als/compendium/AbstractManager/uploads/01125.pdf , 3 pages.	
	NPL4	Kolb, R., "EUV Lithography Making Possible Next Generation of Semiconductors," Sciencebeat [online], June 5, 2001, at http://www.lbl.gov/Science-Articles/Archive/euv_milestone.html (visited January 12, 2003), 4 pages.	
	NPL5	Lee, S. H., High Accuracy EUV Interferometry, at http://buffy.eecs.berkeley.edu/IRO/Summary/99abstracts/shlee.1.html (visited January 12, 2003), 1 page.	
	NPL6	Mansuripur, M., "The Ronchi Test," MM Research, Inc., at http://www.mmresearch.com/articles/article1 (visited January 9, 2003), 12 pages (also published in <i>Optics & Photonics News</i> , July 1997, pp.42-46).	
	NPL7	Measurement Science in the Extreme Ultraviolet: Testing Advance Optics for Printing Integrated Circuits, at http://www.als.lbl.gov/als/actrep/FileH.pdf (visited January 12, 2003), 2 pages.	
	NPL8	Naulleau, P. P., <i>et al.</i> , "Fabrication of high-efficiency multilayer-coated binary blazed gratings in the EUV regime," <i>Optics Communications</i> , Vol. 200, December 15, 2001, Elsevier Science B.V., pp. 27-34.	
	NPL9	Wyant, J. C., "White Light Extended Source Shearing Interferometer," <i>Applied Optics</i> , Vol. 13, No. 1, January 1974, pp. 200-202.	
	NPL10	Search Report from the European Patent Office for European Patent Application No. 04000512.6-2217, mailed January 3, 2005 (3 pages).	

Examiner	Date	
Signature	Considered	

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INFORM	ATION	DISC	CLOSURE	Filing Date	August 29, 2003	
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			s necessary)	Art Unit	2877	
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Sheet	2	of	2	Attorney Docket Number	1857.2080000	

NON PATENT LITERATURE DOCUMENTS							
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume number, publisher, city and/or country where published					
	NPL11	Search Report from the Danish Patent and Trademark Office for Singapore Patent Application No. 200400112-9, mailed August 20, 2004 (7 pages).					
	NPL12	English-language abstract for Japanese Patent Application No. 2000-266914, published September 29, 2000, <i>from</i> www.espacenet.com, 1 page.					
	NPL13	Copy of the Search Report for Singapore Application No. 200400111-1, issued on June 5, 2004.					
	NPL14						
	NPL15						
	NPL16						
	NPL17						
	NPL18						
	NPL19						
	NPL20						

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Examiner	Date	
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